

Customer No.: 31561  
Application No.: 10/709,412  
Docket No.: 11340-US-PA

REMARKS

In response to the Restriction Requirement, mailed on August 23, 2006, a complete listing of all of the claims is presented herewith. Applicant would like to elect Group II, Claims 16-21, drawn to a structure of thin film transistor (TFT), classified in class 257, subclass 49+. Please cancel Group I, Claims 1-15, drawn to a method of fabricating a transistor and patterning an amorphous semiconductor film, classified in class 438, subclass 149+, without waiver, prejudice or disclaimer.

If the Examiner believes that a telephone conference would expedite the examination of the above-identified patent application, the Examiner is invited to call the undersigned.

Date :

*Sept. 19, 2006*

Respectfully submitted,

*Belinda Lee*  
Belinda Lee

Registration No.: 46,863

Jiang Chyun Intellectual Property Office  
7<sup>th</sup> Floor-1, No. 100  
Roosevelt Road, Section 2  
Taipei, 100  
Taiwan  
Tel: 011-886-2-2369-2800  
Fax: 011-886-2-2369-7233  
Email: [Usa@jcipgroup.com.tw](mailto:Usa@jcipgroup.com.tw)